



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 10, 2026

IGI Report Number

LG772639783

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

9.40 X 6.32 X 4.71 MM

GRADING RESULTS

Carat Weight

3.00 CARATS

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

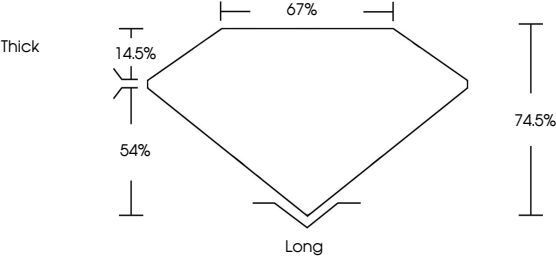
Inscription(s)

 LG772639783

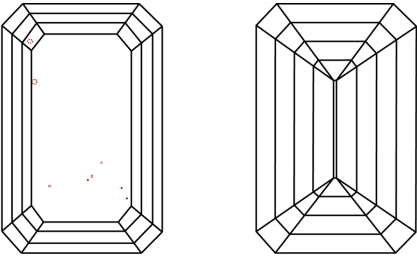
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



February 10, 2026

IGI Report Number

LG772639783

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

9.40 X 6.32 X 4.71 MM

GRADING RESULTS

Carat Weight

3.00 CARATS

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

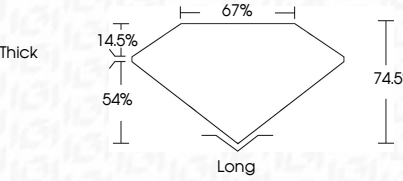
NONE

Inscription(s)

 LG772639783

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS





© IGI 2020, International Gemological Institute

FD - 10 20



IGI

February 10, 2026

IGI Report No LG772639783

EMERALD CUT

9.40 X 6.32 X 4.71 MM

Carat Weight

3.00 CARATS

Color Grade

F

Clarity Grade

VS 1

Depth

74.5%

Table

67%

Girdle

Thick

Culet

Long

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG772639783

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa